JC17 Rec'd PCT/PTO 23 JUN 2005

00862.102568.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: Not Yet Assigned			
KAZUYA NOTSU, ET AL. Application No.: U.S. National Stage of PCT/JP2004/018982, filed December 14, 1004) Group Art Unit: Not Yet Assigned Compared to the Assigned			
Filed: Not Yet Assigned)			
For: SEMICONDUCTOR MEMBER, MANUFACTURING METHOD THEREOF, AND SEMICONDUCTOR DEVICE	:) :) June 22, 2005			

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

For a concise explanation of relevance of the non-English documents, the Examiner is referred to the enclosed English-language abstracts, and to pages 2 and 13 of the specification.

Some of the listed documents were cited in a PCT International Search report mailed February 8, 2005 for International Application No. PCT/JP2004/018982, which is the parent of the present application from which this application claims priority. A copy of this search report is also enclosed.

10/540261

JC17 Rec'd PCT/PTO 23 JUN 2005

Some of the listed documents were cited in a PCT International Search Report mailed March 29, 2005 for International Application No. PCT/JP2004/018981, which is the parent of the present application from which is application claims priority. A copy of this search report is also enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

John A. Krause

Attorney for Applicants Registration No.: 24,613

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)

ATTY DOCKET NO.

00862.102568.

APPLICATION NO,

U.S. National Stage of PCT/JP2004/018982; filed December 14, 2004

APPLICANT			
	KAZUYA	NOTSU,	EI AL.

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10 - 10 - 10 - 10 - 10 - 10 - 10 - 10 -		Not Yet Assigned		Not Yet	Assigned
	U	S. PATENT DOCUMENTS			
DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
5,221,413	06/22/9:	Brasen et al.	117	89	
	FOR	EIGN PATENT DOCUMENTS			
DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
EP 1 248 294 A2	10/09/02	EPO			
JP 2003-178977 A	06/27/03	Japan			Abstract
JP 2003-282464 A	10/03/03	Japan			Abstract
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JP 2004-342975 A	12/02/04	Japan			Abstract
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JP 2003-78140	03/14/03	Japan			Abstract
JP 11-195562	07/21/99	Japan	.		Abstract
JP 7-302889	11/14/9	Japan			Abstract
OTHER (OCUMENT(S)	ncluding Author, Title, Date, Pertinent Pages, Etc.)			
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet_ 1_ of _ 1_